

Corres. and Mail  
**BOX AF**



AF/ 2815  
LFW

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2815**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshiyuki NAKAYAMA

Group Art Unit: 2815

Application No.: 09/582,351

Examiner: C. Chu

Filed: August 11, 2000

Docket No.: 106386

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURE THEREOF,  
CIRCUIT BOARD, AND ELECTRONIC INSTRUMENT

**AMENDMENT AFTER FINAL REJECTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 1, 2004, Office Action, please consider the following:

**Amendment to the Claims**, as listed in the listing of claims; and

**Remarks.**